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## RF magnetron sputtering of GdBa<sub>2</sub>Cu<sub>3</sub>O<sub>7-δ</sub>/ La<sub>0.67</sub>Sr<sub>0.33</sub>MnO<sub>3</sub> Quasi-bilayer films on SrTiO<sub>3</sub> (STO) single-crystal substrates --Manuscript Draft--

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**TITLE:**

**Radio Frequency Magnetron Sputtering of  $\text{GdBa}_2\text{Cu}_3\text{O}_{7-\delta}$ /  $\text{La}_{0.67}\text{Sr}_{0.33}\text{MnO}_3$  Quasi-bilayer Films on  $\text{SrTiO}_3$  (STO) Single-crystal Substrates**

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**KEYWORDS:**

LSMO/ (Gd) BCO films, RF-sputtering, superconductivity, ferromagnetic, nanoparticles, quasi-bilayer film structure

**SHORT ABSTRACT:**

Here, we present a protocol to grow LSMO nanoparticles and (Gd) BCO films on (001)  $\text{SrTiO}_3$  (STO) single-crystal substrates by radio frequency (RF)-sputtering.

**LONG ABSTRACT:**

Here, we demonstrate a method of coating ferromagnetic  $\text{La}_{0.67}\text{Sr}_{0.33}\text{MnO}_3$  (LSMO) nanoparticles on (001)  $\text{SrTiO}_3$  (STO) single-crystal substrates by radio frequency (RF) magnetron sputtering. LSMO nanoparticles were deposited with diameters from 10 to 20 nm and heights between 20 and 50 nm. At the same time, (Gd)  $\text{Ba}_2\text{Cu}_3\text{O}_{7-\delta}$  ((Gd) BCO) films were fabricated on both undecorated and LSMO nanoparticle decorated STO substrates using RF magnetron sputtering. This report also describes the properties of  $\text{GdBa}_2\text{Cu}_3\text{O}_{7-\delta}$ /  $\text{La}_{0.67}\text{Sr}_{0.33}\text{MnO}_3$  quasi-bilayer films structures (*e.g.*, crystalline phase, morphology, chemical composition); magnetization, magneto-transport, and superconducting transport properties were also evaluated.

## INTRODUCTION:

The hole-doped manganite  $\text{La}_{0.67}\text{Sr}_{0.33}\text{MnO}_3$  (LSMO) have unique properties such as wide-band gaps, half-metallic ferromagnetism, and entangled electronic states, which provide extraordinary opportunities for potential spintronic applications<sup>1-4</sup>. Currently, many researchers are endeavoring to take advantage of the unique properties of LSMO to inhabit the vortex movement for high temperature superconducting (HTS) films, such as (RE)  $\text{Ba}_2\text{Cu}_3\text{O}_{7-\delta}$  films (REBCO, RE= rare-earth element)<sup>5-12</sup>. Nanoscale decoration of the substrate surfaces with ferromagnetic nanoparticles will provide well-defined sites for inducing magnetic pinning centers of expected density<sup>13,14</sup>. However, the ability to control the density and geometry of the nanoparticles on highly textured surfaces, such as on single-crystal substrates and highly textured metal substrates is very difficult. Most commonly, nanoparticles are synthesized and coated on surfaces using metal organic decomposition methods<sup>15</sup>, and pulsed laser deposition methods<sup>16,17</sup>. Although pulse laser deposition methods can provide nanoparticles coated on various substrates, it is difficult to realize large area homogeneous nanoparticles deposition. As for metal organic decomposition methods, they are proper for large area deposition of nanoparticles. However, the nanoparticles are often non-uniform and easily damaged by small physical stresses.

Among these techniques, RF-magnetron sputtering has many advantages. Sputtering has a high deposition rate, low cost, and a lack of toxic gas emission. Also, it is easy to expand to large scale area substrates<sup>18,19</sup>. This method provides single-step formation of  $\text{La}_{0.67}\text{Sr}_{0.33}\text{MnO}_3$  (LSMO) nanoparticles, and the nanoparticles are easy to be deposited on single-crystal substrates. RF magnetron sputtering can create large area nanoparticles uniformly on a diverse range of substrates, irrespective of surface texture, and surface roughness<sup>20</sup>. The particle control can be achieved by adjust sputtering time. Homogeneity can be achieved by adjust target-substrate distance. The disadvantage of RF-magnetron sputtering is its lower growth rate for some oxides<sup>21</sup>. In this approach, target atoms (or molecules) are sputtered out of the target by argon ion, and then nanoparticles are deposited on substrates in the vapor phase<sup>22</sup>. Nanoparticles formation occurs on the substrate in a single step<sup>23</sup>. This method is theoretically applicable to any materials including superconducting thin film, resistance film, semiconductor film, ferromagnetic thin film *etc.* However, to date, reports about protocols for depositing ferromagnetic nanoparticles are very scarce.

Here, we demonstrate the deposition of  $\text{GdBa}_2\text{Cu}_3\text{O}_{7-\delta}/\text{La}_{0.67}\text{Sr}_{0.33}\text{MnO}_3$  quasi-bilayer films on  $\text{SrTiO}_3$  (STO) single-crystal substrates by RF magnetron sputtering method. Two kinds of target materials,  $\text{GdBa}_2\text{Cu}_3\text{O}_{7-\delta}$  and  $\text{La}_{0.67}\text{Sr}_{0.33}\text{MnO}_3$  target are used in the process.  $\text{SrTiO}_3$  (STO) single-crystal substrates were coated with  $\text{GdBa}_2\text{Cu}_3\text{O}_{7-\delta}$  films and  $\text{GdBa}_2\text{Cu}_3\text{O}_{7-\delta}/\text{La}_{0.67}\text{Sr}_{0.33}\text{MnO}_3$  quasi-bilayer films.

In this protocol,  $\text{GdBa}_2\text{Cu}_3\text{O}_{7-\delta}/\text{La}_{0.67}\text{Sr}_{0.33}\text{MnO}_3$  Quasi-bilayer films are deposited with RF magnetron sputtering on STO (001) substrates. The target diameter is 60 mm and the distance between the target and substrates is about 10 cm. The heaters are bulbs positioned 1 cm above the substrates. The maximum temperature is 850°C in this system. There are 5 different

substrates in this system. RF magnetron sputtering  $\text{GdBa}_2\text{Cu}_3\text{O}_{7-\delta}/\text{La}_{0.67}\text{Sr}_{0.33}\text{MnO}_3$  quasi-bilayer films consists of two steps, which are the preparation of substrates and the RF magnetron sputtering process. A picture of the sputtering system is shown in **Figure S1**.

## **PROTOCOL:**

### **1. Substrate and Target Preparation**

Note: This section describes the preparation of the sputter deposition chamber and the single crystal  $\text{SrTiO}_3$  (STO) substrates.

1.1. Use 10 mm x 10 mm  $\text{SrTiO}_3$  (STO) single-crystal substrates during the RF magnetron sputtering process.

1.2. Sequentially clean the substrates in isopropanol and deionized water for 10 min each at room temperature in ultrasonic bath. Then dry the substrates with nitrogen, which is for uniform covering of the substrate and good film adherence.

1.3. Mount the (001) STO substrates in the substrate holders with silver powder conductive glue. Load these into the vacuum chamber.

1.4. Mount the LSMO target in the magnetron injection gun, and then reassemble the gun. Test the resistance with an ohmmeter, to avoid a short circuit between the magnetron and the surrounding shield. Close the vacuum chamber is closed and pump down.

1.5. Once the vacuum is lower than  $1 \times 10^{-4}$  Pa, heat the substrates to 850 °C using a heating rate of 15 °C/min. set the target-substrate distance to 8 cm.

1.6. Set the mass flow controller to 10 sccm of O and 5 sccm of Ar as working gas flow. Use Ar/ O mixed gas to keep O cationic ratio (3) for  $\text{La}_{0.67}\text{Sr}_{0.33}\text{MnO}_3$  material during growth.

1.7. Before the deposition, pre-sputter the LSMO target for 20 min at 30 W. High power will lead to cracks in the target and using low power will lead to more time for a clean surface, so we choose 20 min for 30 W.

### **2. LSMO Nanoparticle Deposition**

Note: This section describes the deposition of the LSMO nanoparticles by RF-magnetron sputtering.

2.1. To obtain a chamber pressure of 25 Pa, adjust the molecular pump splint valve. If the instant value is becoming larger than 25 Pa, rotate it counter-clockwise; if it is becoming smaller than 25Pa, rotate it clockwise. Continue until the pressure has settled to a stable value.

2.2. Check that the substrate temperature remains at 850 °C and is stable.

2.3. Increase the power of magnetron from 30 to 80 W. Wait for 10 min, until the plasma is stabilized.

2.4. Open the shutter and deposit LSMO on the heated substrate.

Note: We used sputtering times of 5, 10, 30, and 60 s for four samples.

2.5. Close the shutter. Shut off power to the magnetron. Close the gas valve and shut off heater power.

2.8. Cool the samples to room temperature. Unusually, this takes at least two hours in this system. Vent the chamber with dry nitrogen, open it, and remove the samples.

### 3. $\text{GdBa}_2\text{Cu}_3\text{O}_{7-\delta}$ Film Deposition

3.1. Mount the  $\text{GdBa}_2\text{Cu}_3\text{O}_{7-\delta}$  target in the magnetron gun, then reassemble the gun. Deposit any (Gd) BCO films, using steps similar to steps 1.4-2.8. Use similar deposition conditions for (Gd) BCO films as for the LSMO nanoparticles, except for the sputtering time which should be 30 min. After this, the growth will be over, and next step is the post-annealing.

3.2. Decrease the sample temperature to 500°C. Then, open the gas valve for oxygen to give a chamber pressure of 75,000 Pa. Hold the samples at this temperature for one hour.

Note: The temperature for 500 °C and a chamber pressure of 75, 000 Pa are for uniformly achieving LSMO nanoparticles.

3.3. Cool the samples to room temperature. Vent the chamber with dry nitrogen, open it, and remove the samples.

### REPRESENTATIVE RESULTS:

The thickness of (Gd) BCO films on both bare and LSMO decorated STO substrate was 500nm, which was measured by a surface profilometer. The film thickness was controlled by sputtering time. **Figure 1a,b** shows the AFM image of LSMO nanoparticle (sputtering time of 10 s) on 1.0 cm x 1.0 cm single-crystal STO substrates to prove that the LSMO nanoparticles grown on STO substrates uniformly. The surface and to measure the roughness of the films was characterized by atomic force microscopy (AFM) working in tapping Mode. The diameter of these LSMO nanoparticles ranged from 10 to 20 nm. Their height ranged from 20 to 50 nm. With an appropriate adjustment of deposited parameters, such as growth temperatures and target-substrate distance, different surface topography could be achieved, as shown in **Figure 1c,d**. At a low temperature (650 °C), particle and line mixed topography was obtained, as seen in **Figure 1c**. Furthermore, a small target-substrate distance (6 cm) can lead to a high density of LSMO

particles with small size (**Figure 1d**). The structure of the LSMO nanoparticles (sputtering time of 10 s) and (Gd) BCO films (**Figure 2**) was measured by X-ray diffractometer (XRD) measurement with Cu Ka radiation operated at 40 kV and 20 mA. In **Figure 3**, results are shown for two representative (Gd) BCO samples as described above: (Gd) BCO films on undecorated and LSMO decorated substrates. The superconducting transition temperature ( $T_c$ ) was close to 90.5 K for pure GBCO film and 90.3 K for LSMO/GBCO films. This nearly equal  $T_c$  value indicates LSMO nanoparticles don't harm the superconducting property ( $T_c$ ) for (Gd) BCO films. The higher slope indicate smaller  $T_c$  width for pure GBCO film compared with LSMO/GBCO films. The magnetization hysteresis loops for these two samples are plotted in **Figure 4**. By comparison, the M-H loop area is much bigger from 0 to 6 T at 30K for (Gd) BCO films fabricated on LSMO decorated substrate. The same trend is found at 50 and 77 K.

Representative J-H distributions are also shown for each sample in **Figure 5**. For a given magnetic field, these distributions are calculated as

$$J_c = 2\Delta M \times \left[ a \left( 1 - \frac{a}{3b} \right) \right]^{-1}$$

where a and b are the length and width of the tested sample. A magnetic field, which is perpendicular to the sample plane,  $a < b$ , is applied during testing process. In our case, a and b are 3 mm and 4 mm, respectively. The  $\Delta M$  symbols in the formula is the difference between upper and lower values of a magnetic hysteresis loop at the same H, as shown in **Figure 4**. The critical current density and its dependences of field help will give more information for the effect of LSMO nanoparticles on flux pinning properties. These data in **Figure 5a** suggest that the (Gd) BCO film deposited on LSMO decorated substrate possess a higher  $J_c$  value from 1.3 to 6 T at 30 K. Furthermore, as shown in **Figure 5b**, the (Gd) BCO film fabricated on LSMO decorated substrate shows a higher  $J_c$  value from 0 to 6 T at 77 K. The two phenomena in **Figure 5** suggests that an additional pinning mechanism exist in (Gd) BCO films on LSMO decorated substrates. We named it as magnetic pinning, which is due to LSMO nanoparticles deposited on the substrate.

The pinning force density was calculated by  $F_p = J_c \times B$ . The calculated result is shown in **Figure 6a,b**. There is a crossing point at 1.3T for  $F_p$  (max) value at 30K (**Figure 6a**), above which, the decorated sample has larger  $F_p$  value. The  $F_p$  (max) value at 77K moved to a higher H value (from 0.6 T to 2.5 T) for sample with decoration, which is shown in **Figure 6b**. This difference also indicates there are different pinning mechanisms for (Gd) BCO film with and without LSMO decoration.

We measured the critical current density dependence on magnetic field orientation for obtaining further interesting information on the vortex pinning properties. **Figure 7** shows the angular dependence of  $J_c$  at 0.3T and 77 K for (Gd) BCO film with and without LSMO decoration. It is found that the most prominent increase of  $J_c$  is along the c-axis. This suggests that it is more effective at a field orientation of  $H//c$  for LSMO decorated (Gd) BCO film. For explaining the phenomenon, we show a schematic in the inset of **Figure 7**, which shows threading dislocations generated at  $H//c$  direction. We believe that the threading dislocations along the c-axis in a (Gd) BCO film with LSMO decoration is responsible for this phenomenon.

## FIGURE LEGENDS:

**Figure 1: Atomic Force Microscopic image of LSMO nanoparticle decorated STO substrates. (a) 2D image, (b) 3D image, (c) 3D image of sample grown at a low temperature (650 °C), and (d) 3D image of sample grown at a small target-substrate distance (6 cm).** Reprinted with permission from previous work<sup>12</sup>. Copyright 2018 Elsevier.

**Figure 2: XRD pattern of (Gd) BCO thin films fabricated on undecorated and LSMO nanoparticle decorated STO substrates.** Reprinted with permission from previous work<sup>12</sup>. Copyright 2018 Elsevier.

**Figure 3: DC magnetization measurements of the superconducting transition  $T_c$  for (Gd) BCO thin films fabricated on undecorated and LSMO nanoparticle decorated STO substrates.** Reprinted with permission from previous work<sup>12</sup>. Copyright 2018 Elsevier.

**Figure 4: Magnetization hysteresis loops for (Gd) BCO thin films on the undecorated and LSMO nanoparticle decorated STO substrates at three different temperatures. (a) 30 K, (b) 50 K, and (c) 77 K.** Reprinted with permission from previous work<sup>12</sup>. Copyright 2018 Elsevier.

**Figure 5: Field dependence of  $J_c$  (the critical current density) for (Gd) BCO thin films on undecorated and LSMO decorated STO substrates at (a) 30 K and (b) 77 K.** Reprinted with permission from previous work<sup>12</sup>. Copyright 2018 Elsevier.

**Figure 6: Variation of  $F_p$  as a function of the applied magnetic field for (Gd)BCO films deposited on undecorated and LSMO-nanoparticle-decorated STO substrates. (a) 30 K and (b) 77 K.** Reprinted with permission from previous work<sup>12</sup>. Copyright 2018 Elsevier.

**Figure 7: Dependence of  $J_c$  at 0.3 T and 77 K on orientation of the applied magnetic field, relative to the film's normal direction.** The inset shows the schematic diagram of threading dislocations generated along the c-axis in the LSMO decorated (Gd) BCO thin film. Reprinted with permission from previous work<sup>12</sup>. Copyright 2018 Elsevier.

**Figure S1: Picture of the RF sputtering system**

## DISCUSSION:

Here we have demonstrated that this method can be used to prepare LSMO ferromagnetic nanoparticles of uniform distribution on  $\text{SrTiO}_3$  (STO) single-crystal substrates. The (Gd) BCO films also can be deposited on both bare and LSMO decorated STO substrate. With an appropriate adjustment of deposited parameters, such as growth temperatures and target-substrate distance, this method ought to be useful for deposited different kinds of magnetic and non-magnetic particles or layers, for example,  $\text{CeO}_2$ , YSZ (yttrium-stabilized zirconia)<sup>24</sup>, and ITO (Indium tin oxide).

A critical step in the protocol is the sputtering time for deposition of LSMO particles. In the

protocol, the proper sputtering time is needed. If the sputtering time is too long, this will form continuous LSMO thin film not nanoparticles. On the other hand, if the sputtering time is too short, the density of LSMO nanoparticles is not enough and it will affect current carrying ability for top GBCO films. For GBCO films, in order to achieve epitaxy, the use of a single crystal substrate is needed. In our case, LSMO nanoparticles do not need to achieve epitaxy, but just need greater density and the proper size to enhance top GBCO superconducting properties. In this report, sputtering times are used to control the different morphology for LSMO nanoparticles.

One drawback of our deposition chamber is that because there is no *in situ* QCM (quartz crystal microbalance) sensor, we cannot monitor in real time the film thickness and deposition during the growth process. In our case, the thickness of GBCO films can be controlled by sputtering times. The deposition rate of the GBCO films presented here is about 15 nm/min. Finally, as mentioned in the introduction, the fabrication of LSMO nanoparticles has been successfully achieved by either metal organic decomposition methods (MOD) or pulsed laser deposition methods (PLD). The PLD method possesses slower deposition rates and involves a larger investment, while the MOD method results uniform particle distribution and low reproduction. Concerning the RF sputtering deposition, it can provide particles with uniform distribution and lower investment with respect to PLD method. Also, this nanoparticle deposition procedure can be scaled-up to coat larger surfaces easily.

In conclusion, we demonstrate a RF sputtering method with which to create ferromagnetic LSMO nanoparticles on STO substrate, and GBCO superconducting films on bare and LSMO decorated STO substrate. These ferromagnetic LSMO nanoparticles have never been synthesized by RF sputtering deposition before. This RF sputtering method can coat nanoparticles uniformly on SrTiO<sub>3</sub> (STO) single-crystal substrates or high textured substrates with different particle density and size<sup>17,25</sup>. This feature allows for future application of RF sputtering ferromagnetic nanoparticles in electronics devices on single-crystal substrates or flexible and highly textured substrates.

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#### DISCLOSURES:

The authors have nothing to disclose.

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Figure 1

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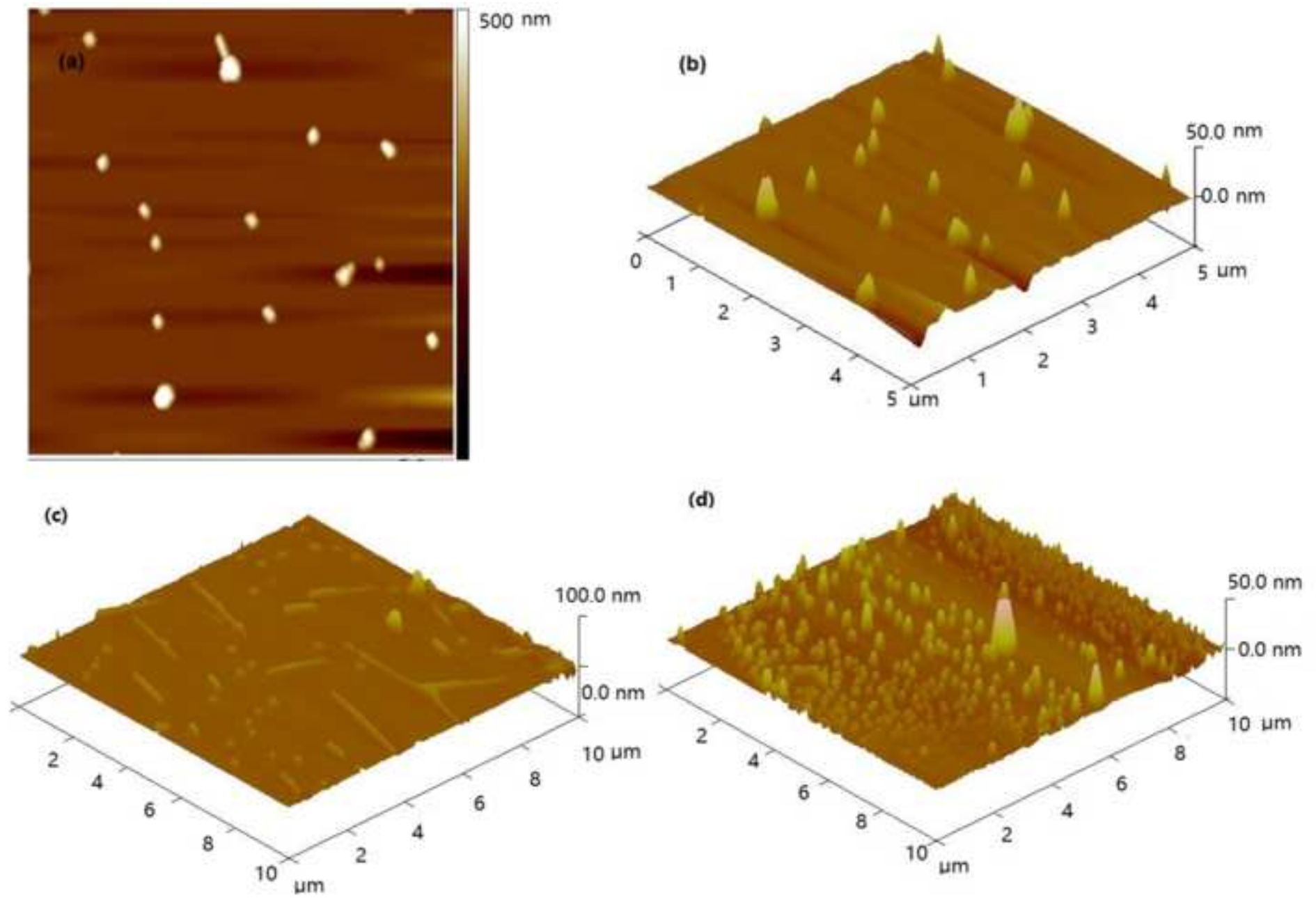


Figure 2

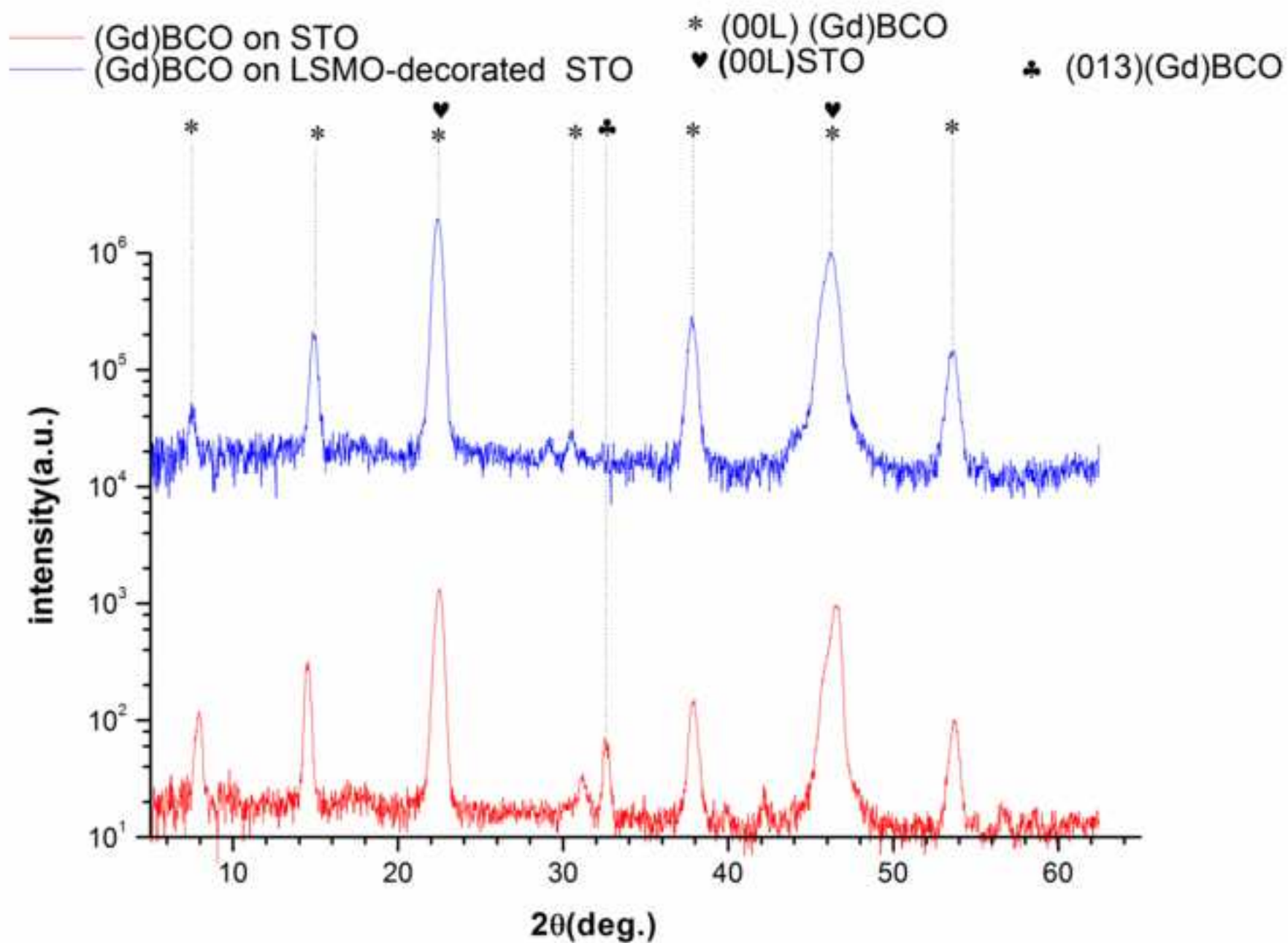


Figure 3

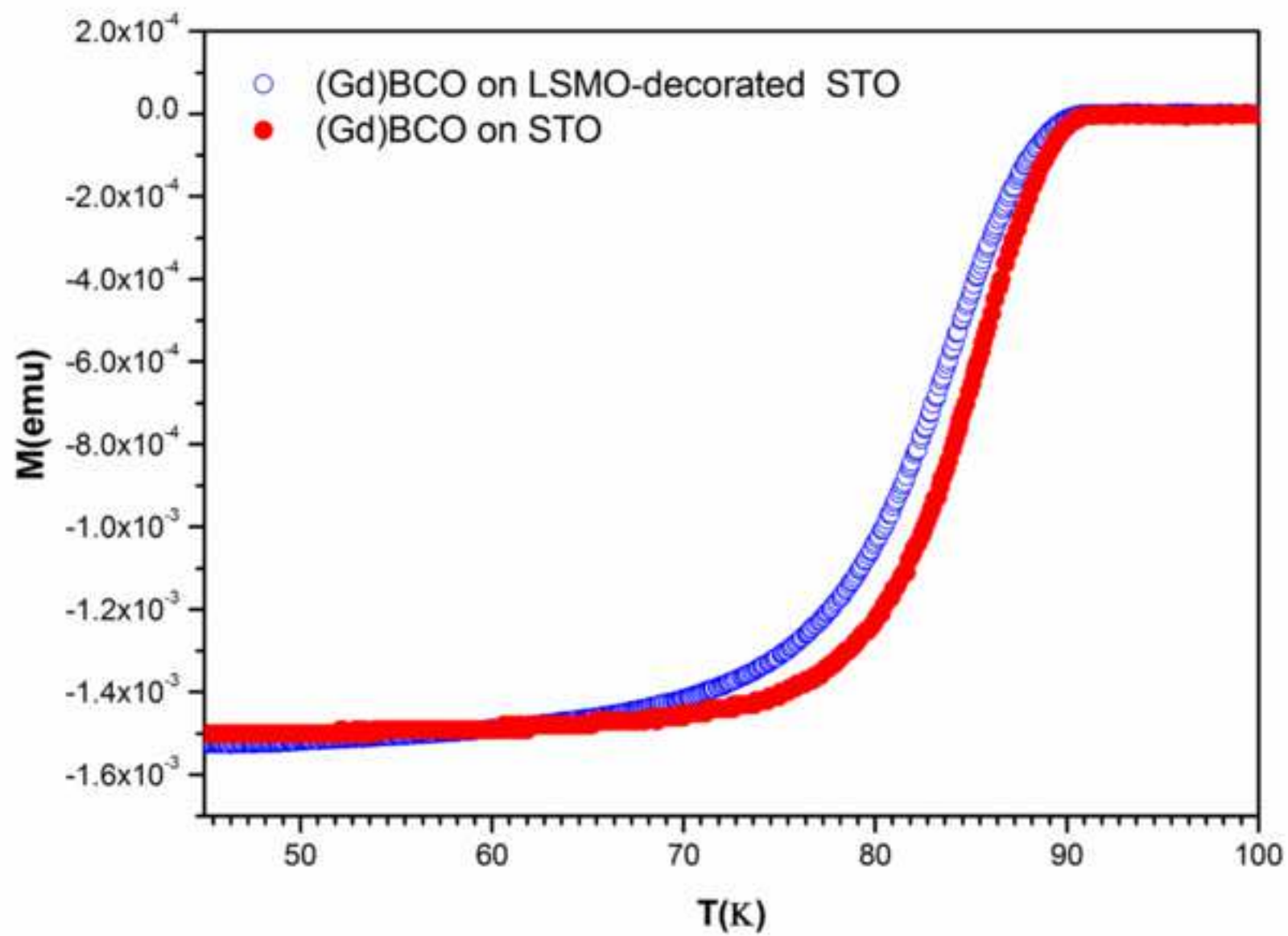


Figure 4

[Click here to access/download;Figure;Fig4 .tiff.tif](#)

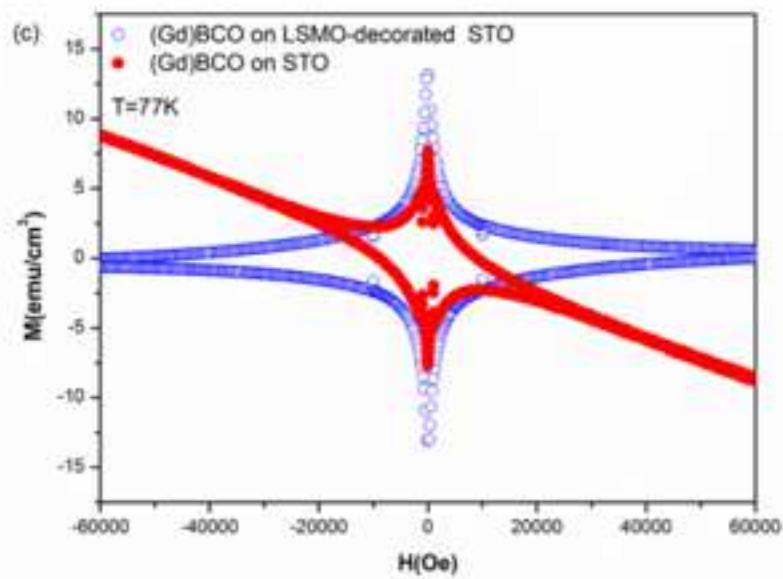
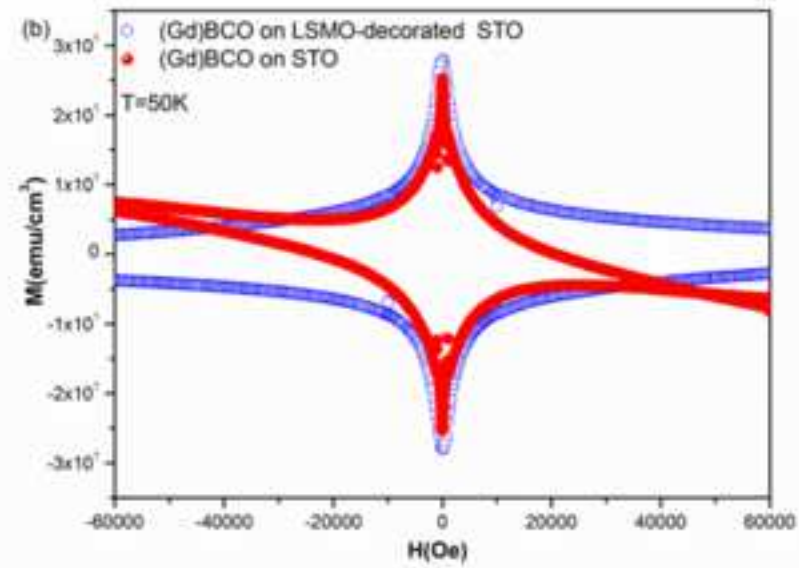
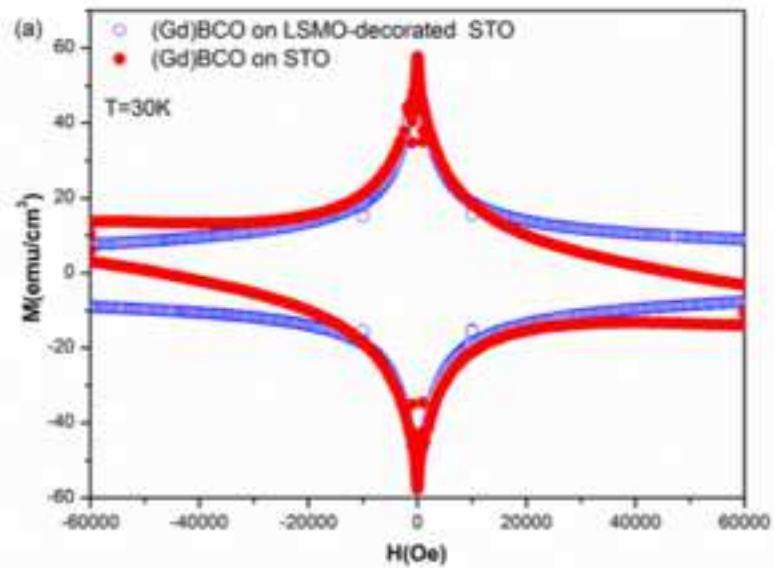


Figure 5

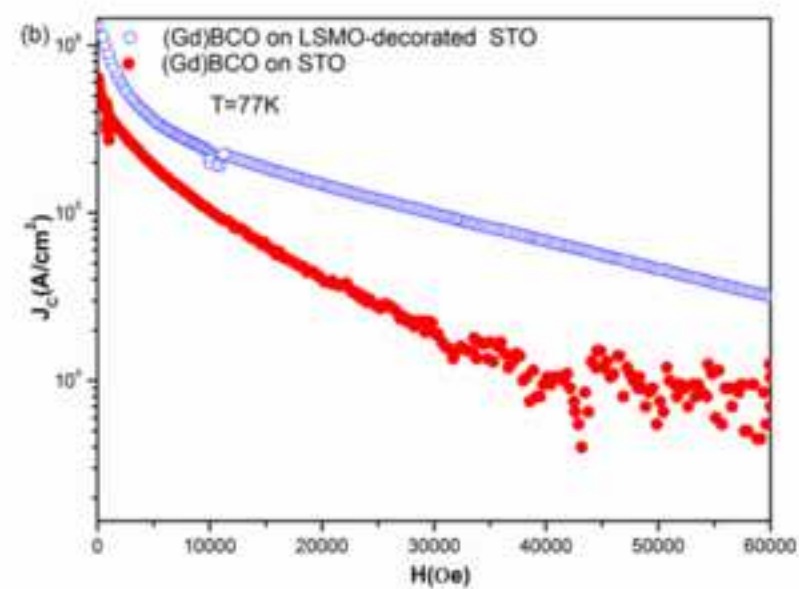
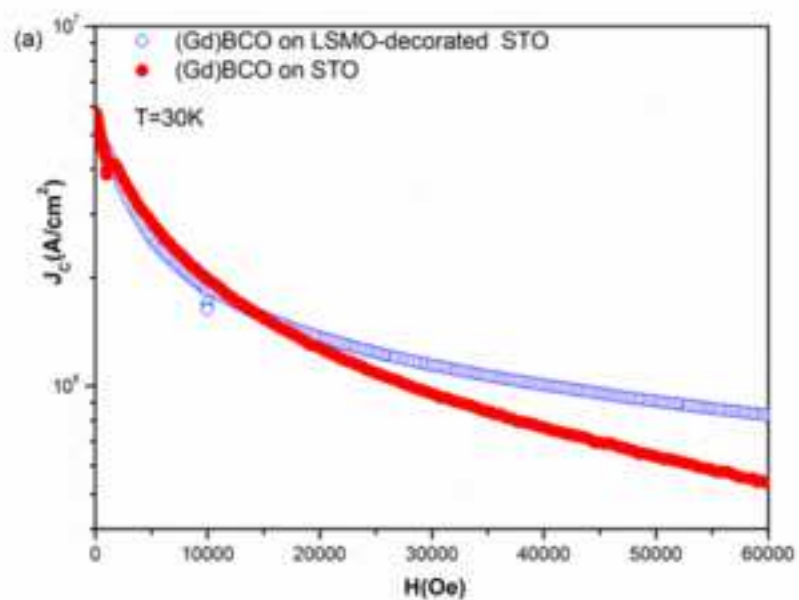




Figure 6

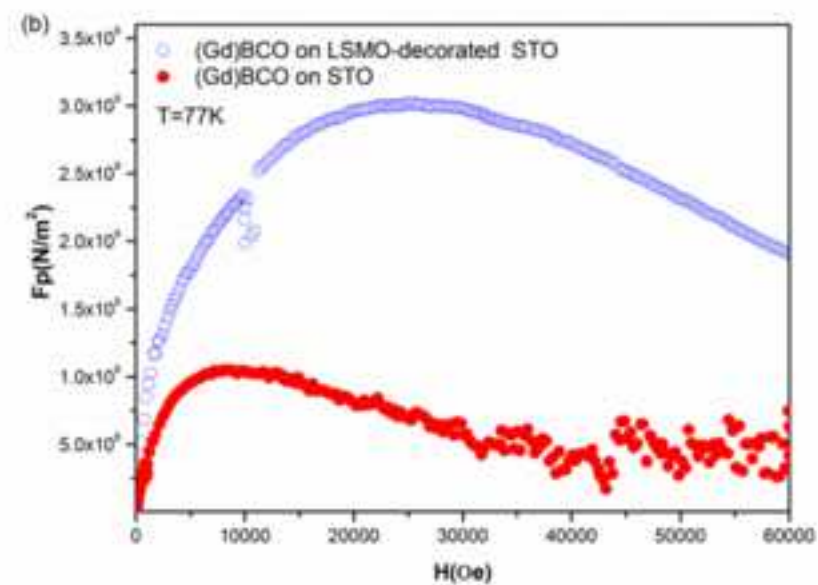
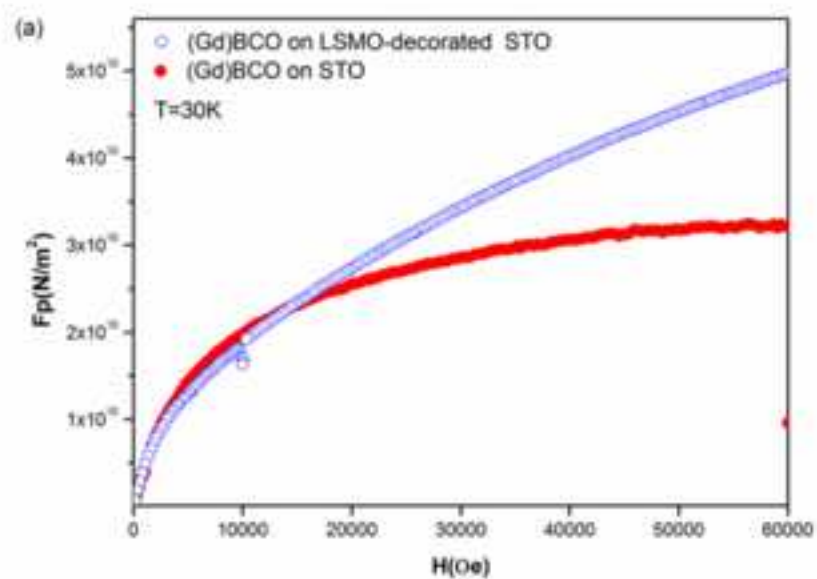
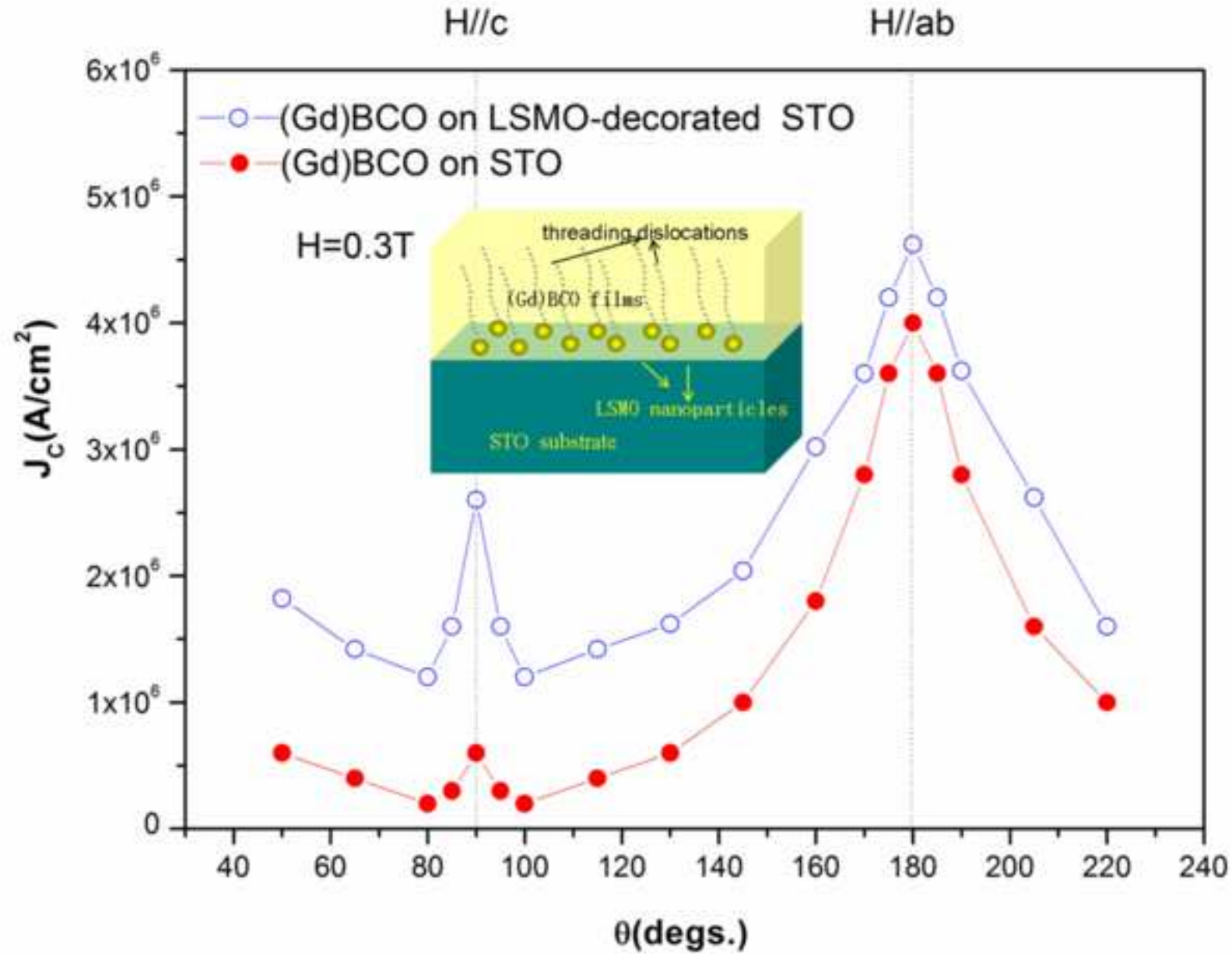




Figure 7



Name of Material/ Equipment	Company	Catalog Number	Comments/Description
Sputter Deposition System	Shenyang scientific instruments Limited by Share Ltd	Bespoke	
SrTiO <sub>3</sub> Single Crystal Substrate	Hefei Kejing crystal material technology Co., Ltd	Single-sided epi-polished	(001) orientation
La <sub>0.67</sub> Sr <sub>0.33</sub> MnO <sub>3</sub> sputtering target	Hefei Kejing crystal material technology Co., Ltd	Bespoke	60 mm diameter
GdBa <sub>2</sub> Cu <sub>3</sub> O <sub>7-δ</sub> sputtering target	Hefei Kejing crystal material technology Co., Ltd	Bespoke	60 mm diameter
Atomic Force Microscope	Brüker	Dimension Icon	
X-ray Diffractometer	Brüker	D8 Discover	
Physical Property Measurement System	Quantum Design	PPMS 9	



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RF magnetron sputtering of  $\text{GdBa}_2\text{Cu}_3\text{O}_{7-x}$  /  $\text{La}_{0.67}\text{Sr}_{0.33}\text{MnO}_3$  Quasi-bilayer films on  $\text{SrTiO}_3$  (STO) single-crystal substrates

Author(s):

Ying Wang<sup>1, 2\*</sup>, Yijie Li<sup>2</sup>, Linfei Liu<sup>2</sup>, Da Xu<sup>2</sup>, Xiaojing Luo Xu<sup>1</sup>

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Dear Dr. Phillip Steindel:

Thank you very much for your kind letter. We have revised the manuscript according to the suggestions made by the Editors. The origin vision of our Article No is JoVE58069. The changes we have made are listed below:

**Editorial comments:**

1. Unfortunately, there are still a few areas of the manuscript that overlap with previous work, including possibly the authors' own. See attached iThenticate report and revise the following: lines 103–106 177–213, and 234–236.

Answer (line107- 109; line181-217; line239-241): According to the suggestions of the editors, we have revised the full text carefully. The details are shown in the text with red colors.

2. There are still some areas of the manuscript where the intended meaning is unclear (see notes in attached manuscript, although there may be other issues); please edit and proofread further.

Answer (line44-45(A1); line103 (A2); line150-151 (A3); line125-127(A4); line171-172(A5)):

According to the suggestions of the editors, we have revised the areas of the manuscript where the intended meaning is unclear carefully.

Commented [A1] (line41–42): This is unclear. Wide-band what? Entangled electronic what? Half-metallic ferromagnetism.

Answer (line44-45(A1)): According to the suggestions of the editors, we have revised wide-band, half-metallic ferromagnet, entangled electronic as wide-band gap, half-metallic ferromagnetism and entangled electronic states, respectively.

Commented [A2] (line100–101): Do you mean ‘used’ , or is it adapted in some non-standard way?

Answer (line103 (A1)): According to the suggestions of the editors, we have revised ‘adapted’ to ‘used’.

Commented [A3] (line105): How is this done?

Answer (line150-151 (A3)): The  $\text{GdBa}_2\text{Cu}_3\text{O}_{7-\delta}$  target prepared process is provided as follows:

Mount the  $\text{GdBa}_2\text{Cu}_3\text{O}_{7-\delta}$  target in the magnetron gun, then reassemble the gun. Deposit any (Gd) BCO films, using steps similar to steps 1.4-2.8.

Commented [A4] (line124–125): How exactly is this done?

Answer (line125-127 (A4)): According to the suggestions of the editors, we have revised as follows:

If the instant value is getting smaller than 25Pa, clockwise rotation it, until the pressure to be settled to a stable value.

Commented [A5] (line169–170): This is unclear; do you mean the diameters/heights ranged between those values.

Answer (line171-172 (A5)): According to the suggestions of the editors, we have revised ‘changed’ to ‘ranged’.

Additionally, we have proofread the article further, and edited the full text carefully, including not properly English expressions and other issues in our article. The details are shown in the text with red colors.

3. In the manuscript, please provide explicit captions for each figure in a separate section.

Answer (List of Figures captions): According to the suggestions of the editors, we have provided

explicit captions for each figure in a separate section (List of Figures captions).

4. Figure 1: Please use ' $\mu\text{m}$ ' instead of 'um' and add spaces between numbers and units (e.g., '0 nm'); also, 'nnm' appears to be a mistake. Lastly, panels c and d do not exist in the current submission.

Answer (Figure 1, line 174): According to the suggestions of the editors, we have revised the 'um' to ' $\mu\text{m}$ ', revised 'nnm' to 'nm'. Also, we have added spaces between numbers and units. panels c and d have been mentioned in line 174.

We are grateful to you and the reviewers for helpful comments. I hope that you and the reviewers will find these changes acceptable. I look forward to hearing from you again.

Sincerely,

Sincerely yours,

Ying Wang

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Figure S1



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